

REISSUE PATENT APPLICATION

# IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re a	pplication	on of:	Confirmation No. 5632			
Brian W. Baird, Michael J. Wolfe, Richard S. Harris, Kevin P. Fahey, Lian-Cheng Zou, and Thomas R. McNeil			I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to			
Applic	ation N	o. 10/017,497	Mail Stop Amendment Commissioner for Patents			
Filed:	Decem	ber 14, 2001	P.O. Box 1450 Alexandria, VA 22313-1450			
For:	PATT	AVIOLET LASER ABLATIVE ERNING OF MICROSTRUCTURES MICONDUCTORS	April 11, 2006  Date Lewe  Signature  Linda Stuwe			
Group	Art Un	it: 1732	Typed Name			
Exami	ner: Dr	. Stefan Staicovici				
Date:	April 1	1, 2006				
		SUPPLEMENTAL INFORMATION DISC	LOSURE STATEMENT			
TO TH	HE COM	IMISSIONER FOR PATENTS:				
1.	Pursuant to the duty of disclosure, applicants present for the Examiner's consideration t documents listed on the accompanying Form PTO-1449.					
	$\boxtimes$	Copies of the listed U.S. patents and U.S. prequired for submission. (37 C.F.R. § 1.98				
		Copies of listed unpublished U.S. patent ap and non-patent literature are enclosed. (37	•			
		Copies of the documents listed on sheet(s) equivalent) are omitted because (1) they are Application No	e already of record in U.S. Patent, on which this application relies 120; and (2) any information n of Application No,			
2.		The Examiner's attention is directed to the Patent Application No, filed which is cited in this application.				

inis in	iiormati	on aisci	osure statement is being submitted (check box a., b., or c.):				
 a. •		Within three months of the filing date of a national application or entry of the national stage in an international application; or before the mailing of a first Office action on the merits; or before the mailing of a first Office action after the filing of a request for continued examination under 37 CFR 1.114. (No statement under 37 CFR 1.97(e) is required.); or					
b.		ne period set forth in paragraph 3a, but before the mailing date of final action, a notice of allowance, or an action that otherwise prosecution in the application. (Check box i. or ii.)					
	i.		A \$180.00 information disclosure statement submission fee set forth in 37 CFR 1.17(p) is enclosed, or				
	ii.		A statement specified by 37 CFR 1.97(e) is set forth below; or				
c.		After the mailing date of a final action or notice of allowance and on or before payment of the issue fee. A statement specified by 37 CFR 1.97(is set forth below. Enclosed is a \$180.00 information disclosure stateme processing fee set forth in 37 CFR 1.17(p).					
d.		Please	charge our Deposit Account No. 19-4455 in the amount of				
		which r	mmissioner is hereby authorized to charge any additional fees may be required in connection with filing of these papers, or credit yment, to Account No. 19-4455.				
		specified states th	d by 37 CFR 1.97(e) is required, the attorney or agent signing at:				
	each item of information contained in the information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the information disclosure statement; or						
	no item of information contained in the information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application, and, to the knowledge of the person signing the certification after making reasonable inquiry, no item of information contained in the information disclosure statement was known to any individual designated in 37 CFR 1.56(c) more than three months prior to the filing of the information disclosure statement.						

3.

4.

5. A concise explanation of the relevance of each document not in the English language and/or selected documents in the English language is set forth below.

The foreign language documents were cited in a Japanese Office action received by applicant's agent on the same day as the Issue Notification. Reference EA is the U.S. patent that corresponds to the Reference EM.

Respectfully submitted,

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Attorney Docket No. 50001/83:2 USA

#### Sheet 1 of 1

FORM PTO-1449 (REV. 7-80)

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# U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

ATTY. DOCKET NO. 50001/83:2 USA

APPLICATION NO. 10/017,497

APR 1 4 2006

INFORMATION DISCLOSURE CITATION (Uses several sheets if necessary)

APPLICANTS
Baird et al.

FILING DATE December 14, 2001 GROUP 1732

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	EA	5,847,960	12/08/1998	Cutler et al.	364	474.29	
	EB						
	EC						
	ED						
-	EE						
	EF						
-	EG						
	EH						
	EI						

#### FOREIGN PATENT DOCUMENTS

EXAMINER		DOCUMENT					TRANSL	ATION
INITIAL		NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	YES	NO
	EJ	11000773	01/06/1999	Japan	B23K	26/00	Machine Translation	1
	EK	4065154	03/02/1992	Japan	B23K	26/06	English Ab Only	stract
	EL	2000164535	06/16/2000	Japan	B23K	26/02	Machine Translation	1
	EM	11510740T	09/21/1999	Japan	B23K	26/00	See Refere	nce EA

### OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

EN	Office action and English Translation concerning the corresponding Japanese Patent Application No. 560,818/2002
ЕО	
EP	

**EXAMINER** 

DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformation with MPEP609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.